3729



## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of:

Toshihiko TANAKA et al.

Appln. No.: 10/045,036 Group Art Unit:

Filed: January 15, 2002 Examiner: T. Phan

For: WIRING SUBSTRATE MANUFACTURING METHOD

## **AMENDMENT**

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

In response to the Office Action mailed April 26, 2005, please amend the above-identified patent application as indicated below.

Amendments to the Specification are reflected on page 2 of this paper.

Amendments to the Claims are reflected in the listing of claims which begins on page 3 of this paper.

Remarks begin on page `7 of this paper.